

PATENT 1FW

Case Docket No. RYUKA.007AUS

Date: July 7, 2004

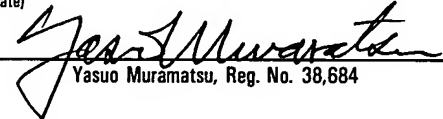
## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Shin-ichi Hashimoto et al.  
App. No. : 10/672,469  
Filed : September 26, 2003  
For : ELECTRON BEAM EXPOSURE APPARATUS,  
DEFLECTION APPARATUS, AND ELECTRON  
BEAM EXPOSURE METHOD  
Examiner : Anthony G. Quash  
Art Unit : 2881

I hereby certify that this correspondence and all marked attachments  
are being deposited with the United States Postal Service as first  
class mail in an envelope addressed to: Commissioner for Patents,  
P.O. Box 1450, Alexandria, VA 22313-1450, on

July 7, 2004

(Date)

  
Yasuo Muramatsu, Reg. No. 38,684

## TRANSMITTAL LETTER

ASSISTANT COMMISSIONER FOR PATENTS  
ALEXANDRIA, VA 22313-1450

Dear Sir:

Transmitted herewith is a response to the office action in the above-identified utility application.

() An extension of time to respond for two month(s) is hereby requested.

Time Extension Fee:

- ☐ one month(\$110 large entity)
- ☐ two months(\$420 large entity)
- ☐ three months (\$950 large entity)

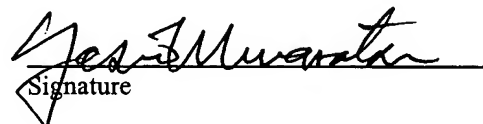
Enclosed are:

(X) Amendment in fourteen (14) pages.

(X) Return prepaid postcard.

SEND ALL CORRESPONDENCE TO:

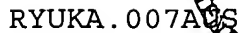
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Signature

Yasuo Muramatsu  
Printed Name

38,684  
Registration Number





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For	:	ELECTRON BEAM EXPOSURE	)	
		APPARATUS, DEFLECTION	)	
		APPARATUS, AND ELECTRON	)	
		BEAM EXPOSURE METHOD	)	
			)	
Examiner	:	Anthony G. Quash	)	
			)	

AMENDMENT

Hon. Commissioner  
of Patents and Trademarks  
Washington, D.C. 20231

Dear Sir:

This amendment is submitted in response to the office action mailed April 8, 2004 from the United States Patent and Trademark Office for the above-identified patent application. Please make the following changes: